



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Peter CHOI

Title: PLASMA SOURCE OF DIRECTED
BEAMS AND APPLICATION THEREOF
TO MICROLITHOGRAPHY

Serial No.: 10/576,105

Filing Date: 30 April 2007

Customer No.: 42419

SECOND INFORMATION DISCLOSURE STATEMENT

Mail Stop AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with Rule 1.56 and MPEP Section 2001.06(a), the reference listed on Form PTO/SB/08a (Sheet 1 of 1) is brought to the attention of the Examiner as being possibly material to the patentability of the subject patent application.

I hereby certify that this correspondence (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

07 December 2010

07 December 2010
Date

Nik Yeller
Signature

Serial No.: 10/576,105

This Second Information Disclosure Statement is filed before a first Office Action.

It is understood that the reference was first cited in a Japanese Office Action for a corresponding Japanese Patent Application.

Form PTO/SB/08a (1 page) is enclosed with a copy of each and every non-U.S. patent reference.

Respectfully submitted,



Nick C. Kottis
Registration No. 31,974

Pauley Petersen & Erickson
2800 West Higgins Road; Suite 365
Hoffman Estates, Illinois 60169
TEL (847) 490-1400
FAX (847) 490-1403